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Article

Linear Electro Optic Effect for High Repetition Rate Carrier Envelope Phase Control of Ultra Short Laser Pulses

Olivier Gobert¹, Daniele Rovera², Gabriel Mennerat¹ and Michel Comte^{1,*}

- ¹ CEA-Saclay, IRAMIS, Service des Photons, Atomes et Molécules, 91191 Gif-sur-Yvette, France; E-Mails: olivier.gobert@cea.fr (O.G.); gabriel.mennerat@cea.fr (G.M.)
- ² LNE-SYRTE, Observatoire de Paris-LNE-CNRS-UPMC, 61 avenue de l'Observatoire, 75014 Paris, France; E-Mail: daniele.rovera@obspm.fr
- * Author to whom correspondence should be addressed; E-Mail: michel.comte@cea.fr; Tel.: +33-1-69-08-59-37; Fax: +33-1-69-08-12-13.

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Abstract: This paper is devoted to analyzing the principle and applications of the linear electro-optic (EO) effect for the control of the carrier-envelope-phase (CEP). We introduce and detail here an original method, which relies on the use of an EO dispersive prism pair in a compressor-like configuration. We show that, by choosing an adequate geometry, it is possible to shift the CEP without changing the group delay (isochronous carrier-envelope-phase shifter) or change the induced group delay without varying the CEP. According to our calculations, when applying an electric field around 400 V/cm to the rubidium titanyle phosphate (RTP) prisms in a double pass configuration (2 × 40 mm total length), one obtains a CEP shift of π rad at 800 nm without inducing a group delay. In contrast, this CEP shift is obtained for an electric field around 1.4 kV/cm in a RTP rectangular slab of the same total length and, in this case, the group delay is of the order of a few fs.

Keywords: electro-optic; carrier-envelope-phase; ultrafast optics; prism compressor; group delay; dispersion

1. Introduction

The electric field of a laser pulse is generally described by the product of a wave envelope and a carrier wave. In a dispersive medium, phase and group velocities are different, inducing a slippage of the carrier frequency wave inside the envelope. For ultra-short pulses containing only a few optical cycles, laser-matter interactions can drastically depend on the electric field and not only on its envelope. In this case, controlling the carrier-envelope-phase (CEP) is of prime importance [1–3].

Because of the difference between effective group and phase velocities in laser cavities and of environmental effects, such as vibrations and thermal drift, the generated pulses from ultra-short chirped pulse amplification (CPA) lasers do not have the same CEP. Various methods have been developed in order to obtain, through the use of a fast control loop, a train of CEP stabilized pulses from mode-locked oscillators [4–6]. Different ways also exist to stabilize the CEP of the amplified pulses of a (CPA) laser system seeded by a CEP stabilized mode-locked oscillator. They are mainly based on a slow feedback loop containing a f-2f interferometer [7], a proportional-integral-derivative controller (PID) and a specific CEP correction technique [8].

Examples of those techniques are the use of a pair of wedges to modify the optical path in the dispersive element composing these wedges [9,10], the modification of one parameter of the compressor or of the stretcher (this parameter can be the distance between the gratings) [11,12], the use of an Acousto-Optic Programmable Dispersive Filter (AOPDF) [13–15] or of a 4f system with an adaptive phase modulator device [16].

We recently proposed an original method based on the linear electro-optic (EO) effect in a bulk material (LiNbO₃—lithium niobate) [17,18] and successfully applied it to the CEP control of a titanium-sapphire CPA laser [19] with stabilization performances of the order of those obtained with classical methods. Compared to the main equivalent CEP shifters (as will be detailed at the end of this paper), the major advantages of EO CEP shifters are related to the fact that they do not need mechanical displacements and especially to their high correction bandwidth (>10 kHz). In this paper, we introduce another original method, still based on the use of the EO effect, but in a more complex optical scheme and which relies on the use of an EO dispersive prism pair. While experimental demonstration of CEP shifts and CEP control [17–19] of CPA amplified pulses with a "longitudinal" shifter (simple rubidium titanyle phosphate (RTP) or LiNbO₃ rectangular slab) has been proven, no experimental results will be given here concerning the prism pair EO shifter, which will be the topic of a future paper.

The structure of the paper is the following. We first recall analytical results explaining how a CEP shift can be induced in an EO crystal, the former being linked to the static electric field dependence of the difference between the induced group and phase delays in the crystal. We then give briefly the main experimental results already obtained with CEP shifters consisting of an EO material rectangular slab (that will be called the "longitudinal configuration" of the CEP shifter in the rest of the paper) on which a transverse electric field is applied. The new prism pair configuration is then theoretically detailed, and it is shown that it has many advantages compared to the first set-up, as, in particular, making it possible to shift the CEP without changing the group delay. This may be essential (typically in high resolution pump-probe experiments and especially in experiments making use of attosecond laser pulses) when any

change in timing between pulses is to be avoided. In the last part of the paper, we provide some elements to compare the different solutions for CEP stabilization.

2. EO CEP Shifter

2.1. Theory

Due to the wavelength dispersion of the refractive index in dispersive media, phase and group velocities have, in general, different values. In a crystal with a non-vanishing EO effect, the refractive index can be linearly modulated by an external electric field, *E*, leading to a variation of the CEP. We consider a laser pulse whose carrier angular frequency is ω_0 , propagating in a homogeneous dispersive medium of length, *L*, which is non-centrosymmetric and exhibits a Pockels effect. This is, for example, the case [17,20] in LiNbO₃—uniaxial crystal, crystalline class 3 m or RTP-biaxial crystal orthorhombic crystalline class mm2—when choosing appropriate directions for the linearly polarized laser field and the applied static electric field. Figure 1 illustrates how the direction of propagation and the polarization of light are to be chosen in practice and how the voltage is to be applied on the crystal in two interesting cases, LiNbO₃ and RTP. *X*, *Y* and *Z* are the principal dielectric axes, which are parallel to the crystallographic axes. With these choices, the variation of the corresponding electric field, *E*. We only consider here the case where one can neglect the change in the crystal length, ΔL , due to the inverse piezoelectric effect, as is the case in LiNbO₃ and RTP [20–22].

Figure 1. Geometry of the interaction for $LiNbO_3$ and simple rubidium titanyle phosphate (RTP). *X*, *Y* and *Z* are the principal dielectric axes (parallel to the crystallographic axes).



The CEP shift, $\Delta \phi_{\text{CEP}}$, after propagation in the EO crystal when applying the electric field is defined by:

$$\Delta\phi_{CEP} = \frac{2\pi}{\lambda} \Big((\tau_g - \tau_{\varphi}) \big[E \big] - (\tau_g - \tau_{\varphi}) \big[0 \big] \Big) \tag{1}$$

For the sake of simplicity, we only consider the case when the change of the refractive index due to the linear EO effect depends on a unique $r(\lambda_0)$ coefficient (unclamped EO coefficient at wavelength λ_0) and can be written in a scalar form as:

$$n(E,\lambda_0) = n_0(\lambda_0) - \frac{1}{2}n_0^3(\lambda_0)r(\lambda_0)E$$
⁽²⁾

where $n_0(\lambda_0) = n(E = 0, \lambda_0)$ is the refractive index without applied field.

Neglecting the inverse piezoelectric effect, one obtains:

$$\Delta\phi_{CEP} \approx 2\pi \left[\frac{3}{2} n_0^2(\lambda_0) r(\lambda_0) \frac{\partial n_0}{\partial \lambda} \right]_{\lambda_0} + \frac{n_0^3(\lambda_0)}{2} \frac{\partial r}{\partial \lambda} \Big]_{\lambda_0} \left] LE$$
(3)

This phase change is proportional to the length, L, of the crystal and to the electric field, E, applied. It can be used to make an active correction of the CEP and maintain its value constant with a control loop, despite environmental fluctuations.

2.2. Experiments

This section presents previously published results demonstrating the validity of our model and giving an example of the performances obtained with the EO shifter. Equation 3 was checked in [17] for LiNbO₃ using a femtosecond 800 nm Ti:S laser source and an f-2f interferometer. The results show a good agreement between theory and experiments. Another approach using spectral interferometry with a broadband laser source [18] was applied to measure CEP shifts and confirmed again, with a better accuracy, the above theory. Stabilization of the CEP (slow loop) of a Ti:S femtosecond laser source was finally demonstrated in [19] with very promising results. The CEP-stable 20W range kHz laser and the EO device for CEP control arrangement is given in Figure 2. In this case, a LiNbO₃ crystal longitudinal EO shifter was used.





Shot to shot and 10 ms averaged measurement of stabilized CEP drift over 10 min of amplified pulses at 3 W output are compared in Figure 3, with and without slow feedback control.

171

Figure 3. Shot to shot (red dots) and 10 ms averaged (grey dots) measurement of stabilized CEP drift over 10 min of amplified pulses at 3 W output (**a**) without slow feedback control, (**b**) with EO feedback loop over 25 min leading to RMS CEP noise of, respectively, 320 and 130 mrad and (**c**) over 7 min of amplified pulses at 20 W output leading to RMS CEP noise of respectively 440 and 250 mrad.



3. Prism Pair CEP Shifter

3.1. Introduction

The EO CEP shifter discussed in the previous part of the document is well-suited to stabilize a high repetition rate CPA Ti:S CEP stabilized mode-locked oscillator system. Nevertheless, for some applications, the CEP shift is not the only relevant parameter. In particular, the electric field-induced group delay $\Delta \tau_g$ ($\Delta \tau_g = 0$ for an isochronous system) and the electric field-induced dispersion $\Delta \Phi_2$ ($\Delta \Phi_2 = 0$ for an iso-dispersive system) may play a role. Furthermore, lowering the applied voltage necessary to obtain the same CEP shift is also clearly of practical interest. Equation 3 shows that the two ways to lower the electric field are to increase the (effective) crystal length or to find a material with optimized characteristics (for example, with a higher EO coefficient).

As can be seen from the theoretical analysis given in paragraph 2.1, the previously described EO CEP shifter configuration is neither rigorously isochronous, nor iso-dispersive, when using $LiNbO_3$ or RTP crystals. We investigated a combination of two CEP shifters with different crystals, but this set-up proved to be ineffective, as it led to very low CEP shifts when a constant group delay (isochronous system) or a constant dispersion condition (iso-dispersive system) were sought.

The idea we propose here is to combine material dispersion with angular dispersion, as in the case of a prism compressor [23], and to study the characteristics of an "EO prism compressor". The prisms are EO crystals (RTP or LiNbO₃ for example) on which an electric field is applied (see Figure 4). In this configuration, the polarization of the optical electric field is parallel to the "static" electric field. This

leads to an S polarization on the prism surfaces and, thus, requires an anti-reflection coating in order to reduce optical losses. The other point, which will be clarified hereafter, concerns the homogeneity of the "static" field in the prisms.



Figure 4. EO prism pair CEP shifter. Yellow parts correspond to gold coating.

3.2. Theory

The induced spectral phase can be written as:

$$\phi(\omega) = \Lambda_{op} \frac{\omega}{c} \tag{4}$$

where Λ_{op} is the optical path for a ray of angular frequency, ω , and c is the speed of light in vacuum.

3.2.1. General Configuration

We first consider the general case where the angle of incidence can take any value. As the optical path is obviously invariant for parallel incident rays, we calculate the path of a ray going through the apex of the first prism (Figure 5). For a single pass in the system, it can be written as:

$$\Lambda_{op} = A_1 B + BC + CD \tag{5}$$

Surprisingly, following the method given in [24], a rather simple calculation shows that it can be written in an elegant mathematical form. We consider (Figure 5) a ray NA₂ parallel to A₁B (NA₁ normal to A₁B) intercepting the apex A₂ of prism 2. This ray is deviated by prism 2 along the path, A₂A₃. As A₁B and NA₂ are parallel incident rays, the light paths, $\Lambda_{opt} = A_1 BCD$ and NA₂A₃, are identical. Let *l* be the distance between the apices of the two prisms and ρ the angle, (NA_2A_1) (Figure 5), the optical pass, Λ_{opt} , can be written as:

$$\Lambda_{op} = l\cos\rho + A_2 A_3 \tag{6}$$

If $(\varphi = \rho + \theta_4)$ is the angle, (A_1A_2O) , between A₁A₂ and A₁O, one obtains the following relation: $\Lambda_{op} = l\cos(\varphi - \theta_4) + A_2A_3 = l\cos\varphi\cos\theta_4 + l\sin\varphi\sin\theta_4 + A_2A_3$

This last equation leads finally to the result:

$$\Lambda_{op} = a\cos\theta_4 + b\sin\theta_4 + A_2A_3 \tag{8}$$

where (Figure 5) θ_4 is the external refraction angle at the exit of prism 1 in air, *a* the slant distance, A₁O, between the output face of prism 1 and input face of prism 2, *b* the distance, OA₂, and A₂A₃ the distance between the apex of the second prism and a reflecting mirror (used in a two pass configuration to remove spatial chirp). A₂A₃ being a constant, we can remove it, and the spectral phase can thus be written:

$$\phi(\omega) = (a\cos\theta_4 + b\sin\theta_4)\omega/c \tag{9}$$

This expression is equivalent to that given in [24]. An analogous calculation was also done in [25], but the above expression was not given.

Figure 5. Geometrical arrangement of the EO prism pair.



The group delay, τ_g , the CEP shift, $\Delta \phi_{CEP}$, and second order dispersion, $\phi^{(2)}$, have, respectively, the following expression:

$$\tau_{g}(\omega) = \frac{\partial \phi}{\partial \omega}$$
(10a)

$$\phi_{CEP}(\omega) = \phi(\omega) - \omega \tau(\omega)$$
(10b)

$$\phi^{(2)}(\omega) = \frac{\partial^{2} \phi}{\partial \omega^{2}}$$
(10c)

Because only the variation of these parameters with the applied static electric field, E, is relevant, we define:

$$\Delta \tau_g(\omega, E) = \tau_g(\omega, E) - \tau_g(\omega, 0)$$
(11a)

$$\Delta \phi_{CEP}(\omega, E) = \phi_{CEP}(\omega, E) - \phi_{CEP}(\omega, 0)$$
(11b)

$$\Delta \phi^{(2)}(\omega, E) = \phi^{(2)}(\omega, E) - \phi^{(2)}(\omega, 0)$$
(11c)

The isochronous CEP shifter condition at carrier angular frequency, ω_0 (CEP shift without induced group delay), corresponds to:

$$\Delta \tau_g(\omega_0, E) = \tau_g(\omega_0, E) - \tau_g(\omega_0, 0) = \frac{\partial \phi}{\partial \omega}(\omega_0, E) - \frac{\partial \phi}{\partial \omega}(\omega_0, 0) = 0$$
(12)

This is to be fulfilled for any value of E. In order to obtain analytical results, we rewrite Equation 2 as:

$$n = n(\omega_0, E) = n_0(1 + \varepsilon E) \tag{13}$$

By derivation with respect to ω , one gets:

$$\frac{dn}{d\omega} = \frac{dn_0}{d\omega} - \eta E \tag{14}$$

with the following relations:

$$n_0 = n(\omega_0, E = 0) \tag{15a}$$

2

$$\varepsilon = -\frac{n_0^2 r_{33}}{2} \tag{15b}$$

$$n_0' = \frac{dn_0}{d\omega}$$
(15c) (15)

$$r_{33} = \frac{dr_{33}}{d\omega}$$
(15d)

$$\eta = -\frac{d(n_0\varepsilon)}{d\omega} = \frac{n_0^2}{2} \left(3r_{33}n_0 + n_0r_{33} \right)$$
(15e)

Using for the refractive index, a first order Taylor expansion as a function of the static electric field, *E*, the isochronous condition leads to the following relation (Appendix I) between *a* and *b*:

$$\frac{b}{a} = tg\theta_{40} - \frac{\varepsilon n_0 n_0 \omega_0 \sin \beta}{\left(\omega_0 \varepsilon n_0 t g^2 \theta_{20} + \omega_0 \eta - n_0 \varepsilon\right) \cos \theta_{20} \cos^3 \theta_{40}} \quad , \tag{16}$$

where θ_{20} and θ_{40} are respectively the values of θ_2 (internal refraction angle in first prism) and θ_4 (external refraction angle in air at the exit of first prism) for E = 0 (Figure 5) and β is the apex angle of the prisms. Similarly, generation of a group delay without variation of the CEP leads to the condition:

$$\Delta\phi_{CEP}(\omega_0, E) = \left[\phi(\omega_0, E) - \phi(\omega_0, 0)\right] - \frac{\partial \left[\phi(\omega_0, E) - \phi(\omega_0, 0)\right]}{\partial \omega}\omega = 0$$
(17)

This situation, that will be called "Pure Group Delay" (PGD) generation in the rest of this paper, implies that *a* and *b* are such that (Appendix II):

$$\frac{b}{a} = tg\theta_{40} - \frac{\varepsilon n_0 n_0 \sin \beta}{\left(\varepsilon n_0 tg^2 \theta_{20} + \eta\right) \cos \theta_{20} \cos^3 \theta_{40}}$$
(18)

Finally, the iso-dispersive condition being:

$$\Delta\phi^{(2)}(\omega_0) = \phi^{(2)}(\omega_0, E) - \phi^{(2)}(\omega_0, 0) = \frac{\partial^2 \phi(\omega, E)}{\partial \omega^2} \bigg|_{\omega_0} - \frac{\partial^2 \phi(\omega, 0)}{\partial \omega^2} \bigg|_{\omega_0} = 0$$
(19)

This leads again to a similar relation. In this case, however, the analytical result is more complex and is not given here for conciseness.

As a first conclusion, we see that for a particular set of the ratio, b/a, that is to say, a specific geometry, it is possible to make the system behave like an isochronous CEP shifter, a PGD generator or an iso-dispersive CEP shifter.

3.2.2. Minimal Deviation Configuration

We now suppose that the incident angle corresponds to the prism minimal deviation at the carrier frequency, ω_0 . This condition, which gives the highest angular dispersion, can be written as:

$$\theta_1 = Arc\sin\{n_0\sin(\beta/2)\}\tag{20}$$

As these parameters are more relevant from an experimental point of view, instead of using the parameters, a and b, we now switch to the parameters, d_2 and d_3 , corresponding, respectively, to the distances covered between prism 1 and 2 in air and to the total path inside the prisms for the ray at the carrier frequency (Figure 6). The spectral phase takes the form (Appendix III):

$$\phi(\omega, E) = \frac{\omega}{c} \left(d_2 \cos\left[\theta_1 - \theta_4(\omega, E)\right] + d_3 \frac{\sin\left[\theta_4(\omega, E)\right]}{2\sin(\beta/2)} \right)$$
(21)

We will now express the results in the particular case of central wavelength, λ_0 , corresponding to the central angular frequency, $\omega_0 = 2\pi c/\lambda_0$, and using λ instead of ω . Equation 21 becomes (Appendix IV):

$$\Delta\phi(\lambda_0, E) \approx \frac{2\pi d_3 n_0 \varepsilon}{\lambda_0} E \tag{22}$$

This shows that, at central wavelength, λ_0 the variation of the spectral phase with respect to the applied electric field does not depend on the distance, d_2 , nor on the apex angle, β .

Figure 6. Geometrical arrangement of the EO prism pair CEP shifter at prism minimal deviation.



The group delay variation with respect to the applied electric field is written:

$$\Delta \tau_{g}(\lambda_{0}) = \frac{E}{c} \begin{bmatrix} 4\varepsilon n_{0}\lambda_{0}d_{2}\frac{dn_{0}}{d\lambda}\frac{\sin^{2}(\beta/2)}{\cos^{2}\theta_{1}} + \\ d_{3}\lambda_{0}\varepsilon\frac{dn_{0}}{d\lambda}\tan^{2}(\beta/2) + d_{3}\left(\varepsilon n_{0} - \lambda_{0}\frac{d(\varepsilon n_{0})}{d\lambda}\right) \end{bmatrix}$$
(23)

where λ is the wavelength corresponding to the angular frequency, ω , and where we use the derivatives taken with respect to the wavelength, λ , instead of ω .

Appl. Sci. 2013, 3

Contrary to the case of the variation of the spectral phase with the electric field, the variation of the group delay with the field depends on d_3 and d_2 . Analytical expression of the group dispersion with respect to the electric field can also be derived, but, as in the general configuration, is not given here for conciseness.

Analytical expressions of the ratio, d_2/d_3 , at $\lambda = \lambda_0$ for isochronous CEP shifter and PGD generator configuration are, respectively, given below:

$$\frac{d_2}{d_3} = \frac{-\lambda_0 \varepsilon \left(\frac{dn_0}{d\lambda}\right) \tan^2 \left(\frac{\beta}{2}\right) + \lambda_0 \left(\frac{d(\varepsilon n_0)}{d\lambda}\right) - \varepsilon n_0}{4\lambda_0 \varepsilon n_0 \left(\frac{dn_0}{d\lambda}\right) \sin^2(\beta)} \cos^2 \theta_1 \quad \text{(Isochronous CEP shifter)}$$
(24)
$$\frac{d_2}{d_2} = \left(\frac{d(\varepsilon n_0)}{d\lambda}\right) - \varepsilon \left(\frac{dn_0}{d\lambda}\right) \tan^2(\beta/2)$$

$$\frac{d_2}{d_3} = \frac{\left(\frac{d\lambda}{d\lambda}\right)^{-\varepsilon} \left(\frac{d\lambda}{d\lambda}\right)^{-\varepsilon} \left(\frac{d\eta}{d\lambda}\right)^{-\varepsilon} \cos^2 \theta_1}{4\varepsilon n_0 \left(\frac{dn_0}{d\lambda}\right)^{-\varepsilon} \sin^2 \left(\beta/2\right)} \cos^2 \theta_1 \qquad (PGD)$$
(25)

When the isochronous CEP shifter configuration is chosen, the variation of the CEP is equal to the variation of the spectral phase with the electric field, which is given by Equation 22.

Another interesting parameter to evaluate is the group-delay dispersion (GDD) induced on the beam by the two prism compressor for E = 0 at $\lambda = \lambda_0$. It can be written in our notations as:

$$\phi^{(2)}(\lambda_{0}) = \frac{2\lambda_{0}^{3}}{\pi c^{2}} \left(-d_{2} \frac{\left(\frac{dn_{0}}{d\lambda}\right)^{2} \sin^{2}(\beta/2)}{\cos^{2}\theta_{1}} + d_{3} \frac{\sin^{2}(\beta/2) \left(-\sin^{2}(\beta/2) \left(\frac{dn_{0}}{d\lambda}\right)^{2} + n_{0} \frac{d^{2}n_{0}}{d\lambda^{2}} \cos^{2}(\beta/2)\right)}{n_{0} \sin^{2}\beta} \right)$$
(26)

From this expression, we deduce the ratio, d_2/d_3 , for which the system introduces no dispersion (*i.e.*, $\phi^{(2)} = 0$) at $\lambda = \lambda_0$:

$$\frac{d_2}{d_3} = \frac{\cos^2 \theta_1 \left(-\left(\frac{dn_0}{d\lambda}\right)^2 \sin^2 \left(\frac{\beta}{2}\right) + n_0 \left(\frac{d^2 n_0}{d\lambda^2}\right) \cos^2 \left(\frac{\beta}{2}\right) \right)}{n_0 \sin^2 \beta \left(\frac{dn_0}{d\lambda}\right)^2}$$
(27)

Analytical results were checked numerically with a ray tracing program.

3.3. RTP Prism Pair CEP Shifter

This paragraph presents numerical results obtained in RTP crystals. The geometry corresponds to Figure 7, with the path length of the ray at the carrier frequency chosen equal in the two crystals.

This geometry is in practice to be preferred in order to obtain an homogeneous "static" electric field in the crystal (which would not be the case at the tip of a prism). The RTP Sellmeier formula for the refractive index is taken from [26] and the wavelength dispersion of the EO coefficients from [20].

Figure 8 plots the ratio, d_2/d_3 , *versus* the apex angle, β , of the prisms when the isochronous $(\Delta \tau_g(\omega_0) = \tau_g(\omega_0, E) - \tau_g(\omega_0, 0) = 0$, thick red), the PGD $(\Delta \phi_{CEP}(\omega_0) = \phi_{CEP}(\omega_0, E) - \phi_{CEP}(\omega_0, 0) = 0$, thick

blue) and the iso-dispersive conditions $(\Delta \phi^{(2)}(\omega_0) = \phi^{(2)}(\omega_0, E) - \phi^{(2)}(\omega_0, 0) = 0$, thin green) are imposed. This gives a means of comparing the performances of each configuration. The thick brown line corresponds to a zero dispersion condition when no electric field is applied $(\phi^{(2)}(\omega_0, E = 0) = 0)$ to the set-up.

Figure 7. Proposed practical geometry for the prism pair CEP shifter set-up.



Figure 8. Ratio, d_2/d_3 , versus apex angle for different configurations and corresponding CEP shift.



It appears that it is not possible to obtain simultaneously an isochronous and iso-dispersive system, nor an isochronous system without dispersion. In the isochronous configuration, the set-up introduces a positive dispersion (as the red curve is on the left of the brown curve, which corresponds to a zero dispersive system at zero electric field). Figure 8 also shows that the PGD configuration (no CEP shift) is very close to the iso-dispersive configuration. This implies that the iso-dispersive configuration should be generally inefficient as a CEP shifter (*i.e.*, will require a far higher voltage to generate the same CEP shift than the isochronous configuration). This is confirmed by looking at the CEP shift, which is plotted (for $d_3 = 40$ mm and E = 1 kV/cm) on the same graph in the iso-dispersive configuration (dotted green line). Finally, the dotted red line curve (which corresponds to the isochronous CEP shift as a function of β) illustrates the fact that, in the isochronous configuration, the CEP shift (at central frequency ω_0 is independent of the apex angle of the prism—as can be seen from Equation 22.

In order to have an idea of the practical values of d_2 corresponding to each configuration, Figure 9 plots the induced CEP shift (red line), the induced group delay (*i.e.*, $\omega_0 \Delta \tau_g$ —blue line) and the induced GDD (brown line) at central frequency, ω_0 , as a function of d_2 . The group delay dispersion, $\phi^{(2)}$ (GDD) for E = 0 is also plotted (dotted brown line). These results are obtained in the case of an apex angle of the prisms, $\beta = 56.5^\circ$, a total path length, $d_3 = 40$ mm, at $\lambda = 800$ nm and a static electric field, E = 1 kV/cm.

Figure 9. CEP shift, $\Delta \tau_g \omega_0$ phase, $\Delta \phi^{(2)}$ and $\phi^{(2)}$ introduced by a RTP prism pair CEP shifter *versus* d_2 for the following parameters (apex angle $\beta = 56.5^\circ$, $d_3 = 40$ mm, E = 1 kV/cm; a value E = 0 kV/cm is assumed for the $\phi^{(2)}$ calculation).



This graph shows again that PGD and iso-dispersive configurations correspond to nearly the same value of d_2 and that the CEP phase shifter is not efficient in the iso-dispersive configuration. One can also conclude that at fixed CEP shift and, for a given pair of prisms, increasing d_2 (*i.e.*, the distance between the prisms) can increase the CEP shift range or reduce the electric field. This, however, cannot be done while maintaining the isochronous condition. In any case, d_2 is limited by the size of the beam on the second crystal, which depends on its spectral extent.

3.4. Comparison between Different CEP Shifters

As different CEP shifters based on various physical phenomena can be found in the literature, it is interesting to compare their performances with the EO CEP shifters. In order to do so, we have restricted ourselves to five systems. These are the AOPDF [4,15], the grating compressor [11,12], the glass wedges system [9,10], the 4f + LCD system [16] and the lens/rotating grating system [27]. Mainly, we chose to compare the induced group delay, $\Delta \tau_g$, and the induced GDD of each system and added, when significant, specific data, such as the mechanical displacement for the grating compressor and the

electric field for the EO devices. Table 1 gives these parameters, when required, for all the systems, for a CEP phase shift of π radians at a wavelength of 800 nm. In the case of the EO CEP shifters, the single pass configuration and the double pass two-wedged crystal isochronous configuration are selected for comparison and a single pass propagation length, L = 40mm, chosen in RTP for the central wavelength rays. This corresponds to RTP crystal lengths, which are commercially available and that lead to relevant CEP shift at moderate values of the electric field. 1,200 grooves/mm gratings were considered at 37° incidence for the grating compressor. Concerning the glass wedge system, the basic configuration described in [10] is considered, with a displacement of two silica wedges perpendicular to the beam axis to vary the thickness of silica. We also give an estimate of the correction bandwidth, defined as the inverse of the time needed to change from one CEP value to another.

	EO CEP Shifter		Dazzler	Grating compressor	Glass wedges	4f + LCD	Lens + rotating grating
	Longitudinal single pass	Prism pair double pass		Double pass			
$\Delta \tau_g$ (fs)	-5.78	0	0	7.9	43.7	0	0
$\Delta \Phi^{(2)} (\mathrm{fs}^2)$	-2	2.6	0	1.7	1	0	0
<i>E</i> (kV/cm)	2.86	-0.43	-	-	-	-	-
Displacement	-	-	-	0.54	-	-	-
(µm)							
Bandwidth	MHz	MHz	<30 kHz	~10–100 Hz	$\sim 1-10 \text{ Hz}$	~10–100 Hz	~1 kHz

 Table 1. Comparison between different CEP shifters.

It is to be noted that the above bandwidths concerning the grating compressor, the glass wedges and the 4f+LCD systems are only to be considered as "typical values". In practice, the effective bandwidth depends on the specific configuration, and the main result to be kept in mind is that their response time is considerably lower than those of the Dazzler or the EO CEP shifter, for example.

4. Conclusions

Compared to the longitudinal EO CEP shifter, the major advantages of the new configuration described here are the possibility to work without induced group delay and the lower static electric field needed for a given CEP shift. In addition, the system can also be used to control a group delay without shifting the CEP (PGD generator). The combination of two such systems should allow us to control separately the CEP and the group delay at a very high speed. The induced GDD can be estimated from table 1 and can be neglected, provided that the condition, $\Delta \phi^{(2)} \leq \tau_p^2 / 10$, is verified. This shows that corrections can be made, even on very short pulses, the most important point being the ability of the system to correct the CEP at a very high speed, which can very probably be extended to the 100 kHz range.

The EO phase shifter cannot be used to stabilize the CEP of the optical pulse train outside the mode-locked (ML) oscillator (see Appendix V). This new set-up should be well suited to stabilizing the CEP of the amplified pulses of a chirped pulse amplification (CPA) laser system seeded by a CEP

stabilized mode locked oscillator (slow feedback loop), as was demonstrated in the case of the longitudinal EO shifter [19].

The authors strongly believe that this type of system could be of interest for different applications, like coherent control, polarization shaping, stabilization of interferometric systems, coherent combination of fiber amplifiers and frequency synthesizers.

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Conflict of Interest

The authors declare no conflict of interest.

Appendix 1: Derivation of the Isochronous Condition (General Case)-Equation 16

As it is obvious that the path length is the same for any ray having the same incident angle, θ_1 , on the first prism, calculations are done in the particular case of a ray intercepting the apex, A₁, of prism 1, as shown on Figure 5.

Figure 10. Incident and refracted angles of the prism pair set-up in the general case.



However, as it is easier to understand the significance of each angle in the general case, we add Figure 10, where the following angles appear:

- β apex angle of the prisms;
- θ_1 incident angle on prism 1;
- θ_2 refracted angle in prism 1;
- θ_3 incident angle on the output face of prism 1;
- θ_4 refracted angle after prism 1 (in air);
- θ_5 incident angle on prism 2;
- θ_6 refracted angle in prism 2;
- $\theta_7 = \theta_1$ incident angle on output face of prism 2.

Clearly, the same angles can be defined in Figure 5. Using Snell's law at each interface with elementary geometrics, the following relations are obtained:

$$\begin{cases} \sin \theta_1 = n \sin \theta_2 \\ \sin \theta_4 = n \sin (\beta - \theta_2) \\ \theta_3 = \beta - \theta_2 \\ \theta_6 = \theta_3 \\ \theta_7 = \theta_1 \end{cases}$$
(A.1)

Equation 9 gives the spectral phase, $\phi(\omega)$, as a function of geometrical parameters, a,b, and the angle, θ_4 (Figure 5). The variation of the group delay, $\Delta \tau_g$, when applying the electric field, *E*, is given by:

$$\Delta \tau_g = \frac{\partial \Delta \phi}{\partial \omega} = \frac{\partial}{\partial \omega} \left(\phi(\omega, E) - \phi(\omega, 0) \right) \tag{A.2}$$

This equation can be rewritten as:

$$c\Delta\tau_g = A + B \tag{A.3}$$

where:

$$A = b(\sin\theta_{40} - \sin\theta_4) + a(\cos\theta_{40} - \cos\theta_4)$$

$$B = b\omega \frac{\partial}{\partial\omega} (\sin\theta_{40} - \sin\theta_4) + a\omega \frac{\partial}{\partial\omega} (\cos\theta_{40} - \cos\theta_4)$$
(A.4)

In these equations, θ_4 and θ_{40} are, respectively, the output angle of prism 1, as defined in Figure 5, when an electric field is applied and when it is not. The isochronous condition corresponds to $\Delta \tau_g = 0$ (no group delay variation due to the application of the electric field).

1.1. Calculation of A

Approximate expressions as a function of E are now to be used. Elementary mathematics show that to the first order of the electric field E:

$$\sin \theta_{4} \approx \sin \theta_{40} + n_{0} \frac{\sin \beta}{\cos \theta_{20}} \varepsilon E$$

$$\cos \theta_{4} \approx \cos \theta_{40} - n_{0} \frac{\sin \beta \sin \theta_{40}}{\cos \theta_{20} \cos \theta_{40}} \varepsilon E$$

$$\sin \theta_{2} \approx \sin \theta_{20} \left(1 - \varepsilon E\right)$$

$$\cos \theta_{2} \approx \cos \theta_{20} \left(1 + \varepsilon E \tan^{2} \theta_{20}\right)$$
(A.5)

where we used the following definitions:

$$n = n_0 \left(1 + \varepsilon E\right)$$

with $\varepsilon = -\frac{n_0^2 r}{2}$ (A.6)

Parameter A can be calculated to the first order of E using the set of Equation A.1:

$$A = b\left(\sin\theta_{40} - \sin\theta_{4}\right) + a\left(\cos\theta_{40} - \cos\theta_{4}\right)$$

$$\approx -bn_{0}\frac{\sin\beta}{\cos\theta_{20}}\varepsilon E + an_{0}\frac{\sin\beta\sin\theta_{40}}{\cos\theta_{20}\cos\theta_{40}}\varepsilon E$$

$$= \frac{n_{0}\sin\beta}{\cos\theta_{20}}\left(an_{0}\tan\theta_{40} - b\right)\varepsilon E$$
(A.7)

This can be rewritten as:

$$A = -n_0 x_{30} \varepsilon E \tag{A.8}$$

It is easy to show that $x_{30} = BC$ (See Figure 5), the light pass in prism 2 without electric field applied, has the following form:

$$x_{30} = \frac{\sin\beta}{\cos\theta_{20}} \left(b - a \times \tan\theta_{40} \right) \tag{A.9}$$

1.2. Calculation of B

Using Snell's law in prism 1, one has:

$$\sin\theta_4 = n\sin(\beta - \theta_2) \tag{A.10}$$

Differentiation of Equation A.10 leads to:

$$\begin{cases}
\frac{\partial \theta_4}{\partial \omega} = \frac{\sin \beta}{\cos \theta_4 \cos \theta_2} \frac{\partial n}{\partial \omega} \\
\frac{\partial \theta_{40}}{\partial \omega} = \frac{\sin \beta}{\cos \theta_{40} \cos \theta_{20}} \frac{\partial n_0}{\partial \omega}
\end{cases}$$
(A.11)

This gives an expression for B:

$$B = \frac{\omega \sin \beta}{\cos \theta_2} (a \times \tan \theta_4 - b) \frac{\partial n}{\partial \omega} - \frac{\omega \sin \beta}{\cos \theta_{20}} (a \times \tan \theta_{40} - b) \frac{\partial n_0}{\partial \omega}$$

= $\omega \left(x_{30} \frac{\partial n_0}{\partial \omega} - x_3 \frac{\partial n}{\partial \omega} \right)$ (A.12)

where x_3 is the light pass in prism 2 when the electric field is applied:

$$x_3 = \frac{\sin\beta}{\cos\theta_2} (b - a \times \tan\theta_4)$$
(A.13)

1.3. Group Delay

Equation A.3, A.8 and A.12 lead to the group delay variation:

$$\Delta \tau_{g} = \frac{1}{c} \Big(\omega \Big(x_{30} n_{0} - x_{2} n' \Big) - n_{0} x_{30} \varepsilon E \Big)$$
(A.14)

We now use the first order expression of *n*, Equation A.6, as a function of *E* to write:

$$\frac{\partial n}{\partial \omega} = \frac{\partial n_0}{\partial \omega} - \eta E \tag{A.15.a}$$

$$d(n, s) = n^2 \tag{A.15.a}$$

with
$$\eta = -\frac{d(n_0\varepsilon)}{d\omega} = \frac{n_0^2}{2} \left(3rn_0' + n_0r' \right)$$
 [see equation (15.e)] (A.15.b)

We then need an approximate expression of x_3 to the first order in *E* as a function of x_{30} . This is obtained using Equation A.13 and the set of Equation A.5. One obtains:

$$x_{3} \approx x_{30} - \left(\frac{an_{0}\sin^{2}\beta}{\cos^{2}\theta_{20}\cos^{3}\theta_{40}} + x_{30}\tan^{2}\theta_{20}\right)\varepsilon E$$

= $x_{30} - (\Gamma + \gamma x_{30})\varepsilon E$ (A.16)

 Γ and γ are defined by:

$$\Gamma = \frac{an_0 \sin^2 \beta}{\cos^2 \theta_{20} \cos^3 \theta_{40}}$$

$$\gamma = \tan^2 \theta_{20}$$
(A.17)

Inserting Equation A.17 in Equation A.14 and using Equation A.16, one obtains the first order in E:

$$c\Delta\tau_{g} = \left[\omega\Gamma\varepsilon n_{0}' + \left(\omega\varepsilon\gamma n_{0}' + \omega\eta - n_{0}\varepsilon\right)x_{30}\right]E$$
(A.18)

where ε and η are given by Equation 15.

The isochronous condition $(\Delta \tau_g = 0)$ leads to a relation between x_{30} and a, which does not depend on *E*. Using Equation A.9 and Equation A.18, one obtains Equation 16.

Appendix 2: Derivation of the Pure Group Delay Condition (General Case)—Equation (18)

The "pure group delay" condition, as defined in section 3.2.1, corresponds to the situation where there is no CEP shift induced by the prisms (and, thus, only a group delay). This condition can be written using the spectral phase as:

$$\Delta\phi_{CEP}(\omega_0, E) = \left[\phi(\omega_0, E) - \phi(\omega_0, 0)\right] - \frac{\partial \left[\phi(\omega_0, E) - \phi(\omega_0, 0)\right]}{\partial \omega}\omega = 0$$
(A.19)

Using Equation 9, one obtains:

$$\Delta\phi_{CEP}(\omega_0, E) = b(\sin\theta_{40} - \sin\theta_4) + a(\cos\theta_{40} - \cos\theta_4) - c\Delta\tau_g = A - c\Delta\tau_g = 0$$
(A.20)

This equation can be rewritten using Equation A.8 and A.18 as:

$$-n_0 \varepsilon x_{30} E - \left(\omega \Gamma \varepsilon n_0' + \left(\omega \gamma \varepsilon n_0' + \omega \eta - n_0 \varepsilon\right) x_{30}\right) E = 0$$
(A.21)

This leads to:

$$x_{30} = \frac{-\varepsilon \Gamma n_0}{\gamma \varepsilon n_0 + \eta} \tag{A.22}$$

Again, using Equation A.9, Equation 18 is obtained.

Appendix 3: Derivation of Equation 21

We first need to consider Figure 6 in order to obtain *a* and *b* as a function of d_1 and d_2 . We immediately see that:

$$a = d_2 \cos \theta_1$$

$$b = d_2 \sin \theta_1 + \frac{d_3}{2\sin(\beta/2)}$$
(A.23)

Replacing these expressions in Equation 9, one obtains:

$$\phi(\omega) = \omega/c \left(d_2 \cos \theta_1 \cos \theta_4 + \left(d_2 \sin \theta_1 + \frac{d_3}{2 \sin(\beta/2)} \right) \sin \theta_4 \right)$$

= $\omega/c \left(d_2 \cos(\theta_1 - \theta_4) + \frac{d_3}{2 \sin(\beta/2)} \sin \theta_4 \right)$ (A.24)

This last equation is equivalent to Equation 21

Appendix 4: Derivation of the Equation 22

Equation 22 gives the spectral phase in the case of minimum deviation and at central frequency, ω_0 . This relation is obtained using Equation 21, which is valid for any frequency. At central frequency, as represented on Figure 6, the following relations take place:

$$\theta_4(\omega_0) = \theta_1(\omega_0)$$

$$\theta_2(\omega_0) = \beta / 2$$
(A.25)

Taking into account Equation A.25 in Equation 21 at $\omega = \omega_0$ and using the central wavelength, λ_0 , instead of the central frequency, ω_0 , one obtains immediately Equation 22.

Appendix 5: Discussion on the Possibility to Stabilize the CEP of a ML Laser Oscillator with an EO System, Outside the Oscillator Cavity

We discuss here the ability of an EO prism pair system to stabilize the CEP of a mode-locked (ML) laser oscillator. The electric field at the output of a mode locked system can be written:

$$E(t) = \sum_{n} E_{p} \left(t - n\tau \right) e^{i\left(\omega_{0}t - n\omega_{0}\tau + n\Delta\varphi_{ce} + \varphi_{0}\right)}$$
(A.26)

In this formula, $\tau = 1/f_{rep}$ is the period between two pulses, ω_0 is the circular carrier wave frequency and $\Delta \varphi_{CE}$ is the phase slippage (modulo 2π) between two pulses. Applying Fourier transform and Fourier series theory, one obtains the following expression [28]:

$$E(\omega) = e^{i\varphi_0} \tilde{E}_p(\omega - \omega_c) \sum_m \delta(\Delta \varphi_{ce} - \omega \tau - 2\pi m)$$
(A.27)

where δ is the Dirac function. This corresponds, as is well known, to a frequency comb, with frequencies given by:

$$\omega_m = -\Delta \varphi_{ce} / \tau + 2\pi m / \tau = f_0 + m f_{rep} \tag{A.28}$$

A method was recently proposed and demonstrated to stabilize the CEP of the optical pulse outside the oscillator cavity [29].



Figure 11. Application of sinusoidal phase modulation at f_{rep}.

This method is based on an acousto-optic device in order to shift the frequency comb. As EO systems are currently used in the ns domain as frequency shifters through a linear temporal phase sweep, it is natural to wonder whether an EO phase CEP shifter could be used to stabilize the CEP of the pulse train outside the ML oscillator by shifting the comb frequencies. To our knowledge, the only way to apply a linear temporal phase shift on every pulse is to use a sinusoidal phase modulator at frequency f_{rep} (or an integer multiple of f_{rep}), as shown on Figure 11. The electric field at the output of the modulator can then be written:

$$E(t) = \left(\sum_{n} E_{p} \left(t - n\tau\right) e^{i\left(\omega_{0}t - n\omega_{0}\tau + n\Delta\varphi_{ce} + \varphi_{0}\right)}\right) e^{i\Gamma\sin\left(\omega_{rep}t\right)}$$
(A.29)

where Γ is the amplitude modulation index, which depends linearly on the radio frequency (RF) electric field applied to the crystal, and ω_{rep} is the angular frequency corresponding to f_{rep} . Applying the Anger-Jacobi development [30] to the last term of Equation A.29 leads to:

$$E(t) = \left(\sum_{n} E_{p}\left(t - n\tau\right)e^{i\left(\omega_{0}t - n\omega_{0}\tau + n\Delta\varphi_{ce} + \varphi_{0}\right)}\right)\left(\sum_{-\infty}^{\infty} J_{k}\left(\Gamma\right)e^{ik\omega_{rep}t}\right)$$
(A.30)

In the spectral domain, the electric field has the following form:

$$\tilde{E}(\omega) \propto e^{i\varphi_0} \left(\tilde{E}_p(\omega - \omega_0) \sum_m \delta(\omega - m\omega_{rep} + \omega_0) \right) * \left(\sum_{-\infty}^{\infty} J_k(\Gamma) \delta(\omega - k\omega_{rep}) \right)$$
(A.31)

where the symbol * stands for the convolution product and J_k are Bessel functions. This last expression can be written as:

$$E(\omega) \propto \sum_{k=-\infty}^{\infty} \left(J_k(\Gamma) \left(\tilde{E}_p(\omega - \omega_0 - k\omega_{rep}) \sum_m \delta(\omega - m\omega_{rep} + \omega_0) \right) \right)$$
(A.32)

This shows that the EO device shifts the spectral envelope, but not the frequencies of the comb, as is the case with the acousto-optic device. This can be easily understood if one considers, on one side, a single pulse on which a linear temporal phase is applied and whose spectrum is shifted by $\Gamma \omega_{rep}$, and, on

the other side, a single mode of the comb, whose temporal extension is infinite and which experiences a sinusoidal phase modulation, giving rise to adjacent modes separated by a multiple of ω_{rep} . This shows that it is not possible to stabilize in this way the CEP of the optical pulse train outside the ML oscillator with our EO device.

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